

**WEST**[Help](#)[Logout](#)[Main Menu](#)[Search Form](#)[Posting Counts](#)[Show S Numbers](#)[Edit S Numbers](#)[Generate Collection](#)**Search Results - Record(s) 1 through 15 of 15 returned.**☐ 1. Document ID: US 5963840 A

Entry 1 of 15

File: USPT

Oct 5, 1999

US-PAT-NO: 5963840

DOCUMENT-IDENTIFIER: US 5963840 A

TITLE: Methods for depositing premetal dielectric layer at sub-atmospheric and high temperature conditions

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 2. Document ID: US 5939831 A

Entry 2 of 15

File: USPT

Aug 17, 1999

US-PAT-NO: 5939831

DOCUMENT-IDENTIFIER: US 5939831 A

TITLE: Methods and apparatus for pre-stabilized plasma generation for microwave clean applications

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 3. Document ID: US 5935340 A

Entry 3 of 15

File: USPT

Aug 10, 1999

US-PAT-NO: 5935340

DOCUMENT-IDENTIFIER: US 5935340 A

TITLE: Method and apparatus for gettering fluorine from chamber material surfaces

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 4. Document ID: US 5935334 A

Entry 4 of 15

File: USPT

Aug 10, 1999

US-PAT-NO: 5935334

DOCUMENT-IDENTIFIER: US 5935334 A

TITLE: Substrate processing apparatus with bottom-mounted remote plasma system

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 5. Document ID: US 5933760 A

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Sections Requested  
Front Page, Drawings, Specifications, Claims, Changes/Corrections, Reexaminations

(01) 04631803 U

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Time: 18:04:38

Date: Thu Sep 30, 1999

Printer Id: \USPTO-FP-GBJ\CP4\_4C04-GBJ\PTR

Workstation Id: ws09964

User Phone: 0003080956

User Name: GPeralta

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Entry 5 of 15

File: USPT

Aug 3, 1999

US-PAT-NO: 5933760

DOCUMENT-IDENTIFIER: US 5933760 A

TITLE: Method and apparatus for reducing fixed charge in semiconductor device layers

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 6. Document ID: US 5925189 A

Entry 6 of 15

File: USPT

Jul 20, 1999

US-PAT-NO: 5925189

DOCUMENT-IDENTIFIER: US 5925189 A

TITLE: Liquid phosphorous precursor delivery apparatus

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 7. Document ID: US 5879574 A

Entry 7 of 15

File: USPT

Mar 9, 1999

US-PAT-NO: 5879574

DOCUMENT-IDENTIFIER: US 5879574 A

TITLE: Systems and methods for detecting end of chamber clean in a thermal (non-plasma) process

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 8. Document ID: US 5862057 A

Entry 8 of 15

File: USPT

Jan 19, 1999

US-PAT-NO: 5862057

DOCUMENT-IDENTIFIER: US 5862057 A

TITLE: Method and apparatus for tuning a process recipe to target dopant concentrations in a doped layer

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 9. Document ID: US 5814377 A

Entry 9 of 15

File: USPT

Sep 29, 1998

US-PAT-NO: 5814377

DOCUMENT-IDENTIFIER: US 5814377 A

TITLE: Method and apparatus for creating strong interface between in-situ SACVD and PECVD silicon oxide films

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 10. Document ID: US 5812403 A

Entry 10 of 15

File: USPT

Sep 22, 1998

US-PAT-NO: 5812403

DOCUMENT-IDENTIFIER: US 5812403 A

TITLE: Methods and apparatus for cleaning surfaces in a substrate processing system

User Name: GPeralta

User Phone: 0003080956

Workstation Id: ws09964

Printer Id: \USPTO-FP-CBJJCP4\_4C04\_CBJJPTR

Date: Thu Sep 30, 1999

Time: 18:04:41

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Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 11. Document ID: US 5753303 A

Entry 11 of 15

File: USPT

May 19, 1998

US-PAT-NO: 5753303

DOCUMENT-IDENTIFIER: US 5753303 A

TITLE: Process for the elimination of tungsten oxidation with inert gas stabilization in chemical vapor deposition processes

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 12. Document ID: US 5648175 A

Entry 12 of 15

File: USPT

Jul 15, 1997

US-PAT-NO: 5648175

DOCUMENT-IDENTIFIER: US 5648175 A

TITLE: Chemical vapor deposition reactor system and integrated circuit

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 13. Document ID: US 5646075 A

Entry 13 of 15

File: USPT

Jul 8, 1997

US-PAT-NO: 5646075

DOCUMENT-IDENTIFIER: US 5646075 A

TITLE: Method for optimizing thermal budgets in fabricating semiconductors

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 14. Document ID: US 5474955 A

Entry 14 of 15

File: USPT

Dec 12, 1995

US-PAT-NO: 5474955

DOCUMENT-IDENTIFIER: US 5474955 A

TITLE: Method for optimizing thermal budgets in fabricating semiconductors

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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☐ 15. Document ID: US 5104482 A

Entry 15 of 15

File: USPT

Apr 14, 1992

US-PAT-NO: 5104482

DOCUMENT-IDENTIFIER: US 5104482 A

TITLE: Simultaneous glass deposition and viscoelastic flow process

Full	Title	Citation	Front	Review	Classification	Date	Reference	Claims	KWIC	Image
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Terms	Documents
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